

# Epitaxially Integrating Ferromagnetic Fe<sub>1.3</sub>Ge Nanowire Arrays on Few-Layer Graphene

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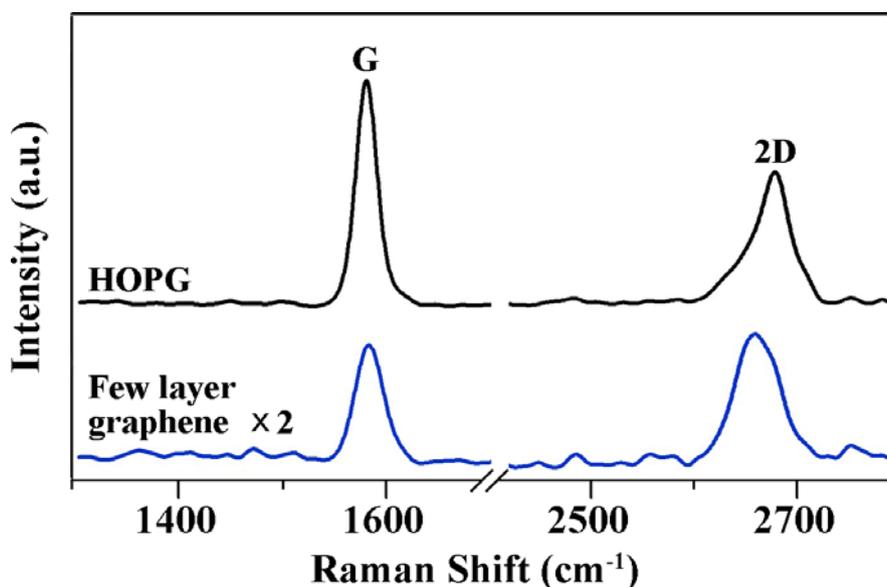
## Supporting information:

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## 1. Identification of graphene



**Figure S1.** Raman spectra of HOPG and graphene/SiO<sub>2</sub>/Si substrates.

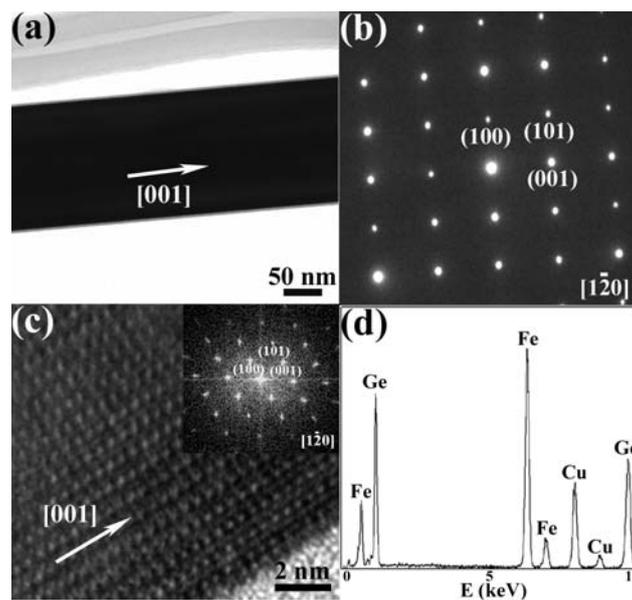
Figure S1 shows the Raman spectra of HOPG and graphene/SiO<sub>2</sub>/Si substrates. Raman spectra were collected from a micro-Raman system based on Olympus BX41 microscope. The 633 nm radiation of a He-Ne laser (Melles Griot) was used as an excitation source and the laser was focused through a ×100 objective (NA = 0.7, Mitutoyo). The signals were recorded with a thermodynamically cooled electron multiplying charge coupled device (EMCCD, Andor) mounted on the spectrometer with a 1200 groove/mm grating. The collection time was 100 s.

The major features in the Raman spectra of HOPG and graphene are the G and D bands and the second order of the D band (2D band). The G band at ~1580 cm<sup>-1</sup> is due to E<sub>2g</sub> vibration mode, corresponding to in-plane carbon atom stretching vibrations.<sup>S1</sup> This band becomes more intense with increasing layer numbers due to more carbon atoms contributing to this vibration mode. The D and 2D bands at ~1350 cm<sup>-1</sup> and 2700 cm<sup>-1</sup>, respectively, are induced by two-phonon mode.<sup>S1</sup> The D band requires defects for its activation, therefore, it is absent for perfect crystalline samples.<sup>S2,S3</sup> The 2D band, on the contrary, always exists even if its first order is absent and shows a significant change as the

number of layers is decreased.<sup>S1</sup> In Figure S1, the well-isolated G and 2D bands are presented and D band is absent in both spectra, attesting to the high crystalline quality of samples. For a graphene/SiO<sub>2</sub>/Si substrate, the G band is decreased and 2D band is blue-shifted comparing to Raman bands of HOPG. This confirmed that the graphene is only few layers (3-5).<sup>S2-S4,12</sup>

Furthermore, the size of graphene flakes may vary from about a few hundred nanometers to several micrometers similar to the grain sizes of employed Ni film<sup>S5,12</sup> because it has been assumed that the size of graphene flakes can be influenced by an underlying Ni grain size.<sup>S6</sup>

## 2. TEM analysis of Fe<sub>1.3</sub>Ge NWs on graphene

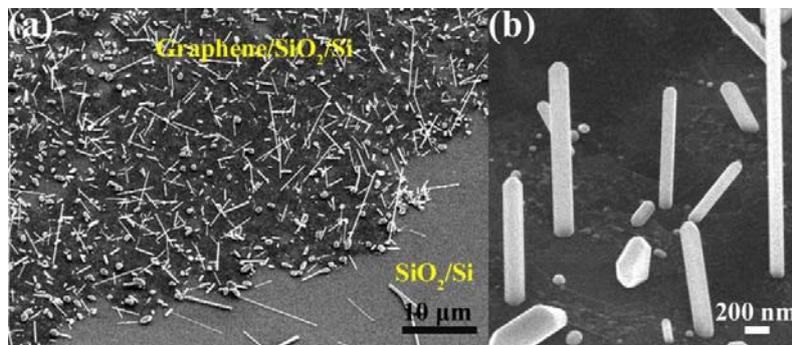


**Figure S2.** (a) TEM image and (b) SAED pattern of a Fe<sub>1.3</sub>Ge NW grown on a graphene. The SAED pattern is indexed to a hexagonal Fe<sub>1.3</sub>Ge down the  $[\bar{1}20]$  zone axis. (c) HRTEM image of a Fe<sub>1.3</sub>Ge NW and its FFT (inset in panel (c)). The growth direction of the Fe<sub>1.3</sub>Ge NW is parallel to the [001] direction. (d) TEM-EDS spectrum of a Fe<sub>1.3</sub>Ge NW reveals that Fe and Ge are the only elements present

in the NW in an average atomic ratio of 56 : 44.

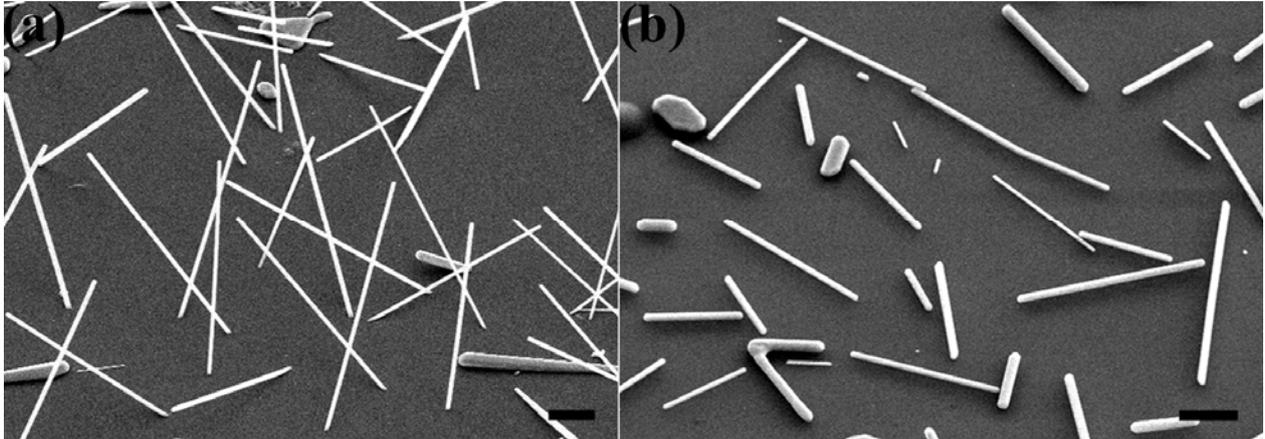
Figures S2a and S2b show TEM image and a selected area electron diffraction (SAED) pattern, respectively, obtained from a NW grown on graphene. The NW shows a regular SAED spot pattern, reflecting the single-crystalline nature with the spots matching well to the hexagonal  $\text{Fe}_{1.3}\text{Ge}$  structure. Figure S2c shows a HRTEM image of a  $\text{Fe}_{1.3}\text{Ge}$  NW, a two-dimensional FFT (inset in panel S2c) of which could be indexed to the hexagonal  $\text{Fe}_{1.3}\text{Ge}$  structure, indicating a [001] NW growth direction. EDS data (Figure S2d) obtained from the NW exhibits that only Fe and Ge are present in the NW in an average atomic ratio of 56 : 44.

### 3. $\text{Fe}_{1.3}\text{Ge}$ NWs grown on a graphene/ $\text{SiO}_2$ /Si substrate



**Figure S3.** (a) Tilted view SEM image of freestanding  $\text{Fe}_{1.3}\text{Ge}$  NWs grown on a graphene/ $\text{SiO}_2$ /Si substrate. (b) A magnified SEM image of vertical NWs and inclined NWs grown on the graphene/ $\text{SiO}_2$ /Si substrate.

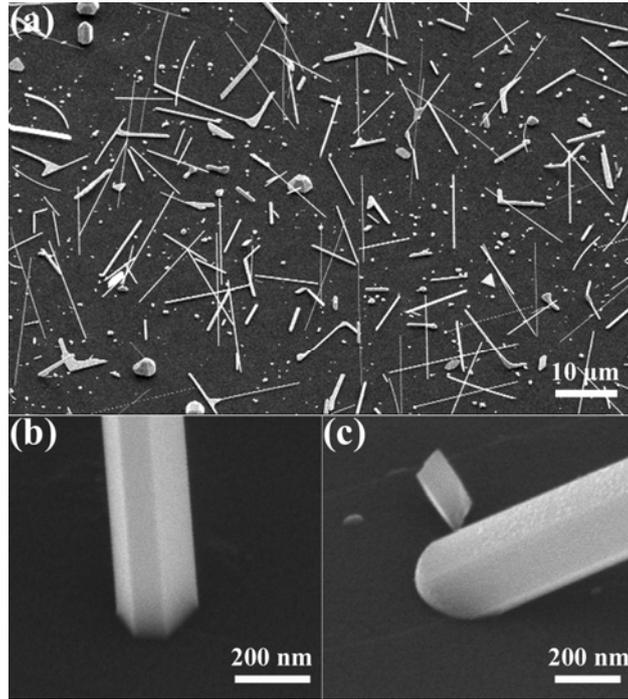
#### 4. Fe<sub>1.3</sub>Ge NWs grown on a *c*-cut sapphire substrate and a SiO<sub>2</sub>/Si substrate



**Figure S4.** Tilted SEM images of as-grown Fe<sub>1.3</sub>Ge NWs grown on (a) a *c*-cut sapphire substrate and (b) a SiO<sub>2</sub>/Si substrate (scale bars: 2 $\mu$ m).

Inclined and horizontal NWs were synthesized on the sapphire substrate and the SiO<sub>2</sub>/Si substrate not covered by graphene as shown in Figure S4.

## 5. Fe<sub>1.3</sub>Ge NWs grown on an HOPG substrate



**Figure S5.** (a) Tilted SEM image of as-grown Fe<sub>1.3</sub>Ge NWs on an HOPG substrate. Enlarged SEM images of (b) a vertical NW and (c) an inclined NW on the HOPG substrate.

## 6. Additional FE data

Insets in Figure 3 show Fowler-Nordheim (F-N) plots obtained from the  $J$ - $E$  results of Fe<sub>1.3</sub>Ge NWs on graphene/ITO and HOPG, respectively. The F-N relationship can be expressed by the following equation:

$$J = (A\beta^2 E^2 / \Phi) \exp(-B\Phi^{3/2} / \beta E)$$

where  $J$  is the local current density,  $E = V/d$  is the applied field,  $V$  is the applied voltage,  $d$  is the distance between the anode and cathode,  $I$  is the current,  $\Phi$  is the work function, and  $A$  and  $B$  are constants, corresponding to  $1.56 \times 10^{-10}$  (AV<sup>-2</sup>eV) and  $6.83 \times 10^3$  (eV<sup>-3/2</sup>Vμm<sup>-1</sup>), respectively.<sup>16-18,29-32</sup> The field enhancement factor,  $\beta$ , reflects the degree of FE enhancement due to the NWs. The  $\beta$  value is related to the geometry, crystal structure, and the density of emitting points of the NWs.  $\beta$  can be

calculated from the slope of the F–N plot if the work function of the emitter is known. Because the work function of Fe<sub>1.3</sub>Ge has not been reported to date, we calculated the approximate work function of Fe<sub>1.3</sub>Ge by applying the following equation suggested by Freeouf<sup>S7,S8</sup>

$$\Phi_{(M_xGe_y)} = [\Phi_{(M)}^x \Phi_{(Ge)}^y]^{1/(x+y)}$$

where  $\Phi_{(M_xGe_y)}$  is the work function of a metal germanide M<sub>x</sub>Ge<sub>y</sub>,  $\Phi_{(M)}$  is the work function of a metal, and  $\Phi_{(Ge)}$  is the Ge work function. The  $\Phi_{(Fe)}$  value of Fe and  $\Phi_{(Ge)}$  value of Ge were previously reported to be 4.7 eV<sup>S9</sup> and 4.8 eV,<sup>S10</sup> respectively. Using these values, the approximate  $\Phi_{(Fe1.3Ge)}$  value of the Fe<sub>1.3</sub>Ge was obtained as ~ 4.74 eV. Employing the slopes obtained from the ln(I/V<sup>2</sup>)–1/V plots (insets in Figure 3) and the  $\Phi_{(Fe1.3Ge)}$  value,  $\beta$  values of the NWs grown on the graphene and the HOPG are calculated to be ~ 4650 and ~ 7300, respectively.

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